



PATENT
Attorney Docket No.: 16869N-111900US
Client Reference No.: NT1530US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Shunji KAWAMURA et al.

Application No.: 10/808,946

Filed: March 24, 2004

For: DATA PROCESSING SYSTEM

Examiner: Gabriel L. Chu

Art Unit: 2114

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT UNDER 37
CFR §1.97 and §1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

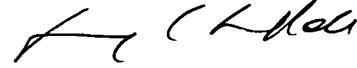
The references cited on attached form PTO/SB/08A are being called to the attention of the Examiner. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR §1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the

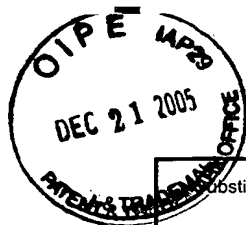
undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



Chun-Pok Leung
Reg. No. 41,405

TOWNSEND and TOWNSEND and CREW LLP
Two Embarcadero Center, Eighth Floor
San Francisco, California 94111-3834
Tel: 650-326-2400
Fax: 650-326-2422
RL:rnh
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Substitute for form 1449A/PTO		Complete if Known	
		Application Number		10/808,946	
		Filing Date		March 24, 2004	
		First Named Inventor		Shunji Kawamura	
		Art Unit		2114	
		Examiner Name		Gabriel L. Chu	
Sheet	1	of	1	Attorney Docket Number	16869N-111900US

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Kind Code ² (if known)			
	1	US 2005/0172166	08-04-2005	Eguchi et al.	
	2	US 2005/0144380	06-30-2005	Suzuki et al.	
	3	US 2005/0132155	06-16-2005	Kasako	
	4	US 2005/0125617	06-09-2005	Ninose et al.	
	5	US 2005/0125465	06-09-2005	Arakawa et al.	
	6	US 2005/0114467	05-26-2005	Ikegaya et al.	
	7	US 2005/0055523	03-10-2005	Suishu et al.	
	8	US 2005/0038968	02-17-2005	Iwamura et al.	
	9	US 2005/0033828	02-10-2005	Watanabe	
	10	US 2004/0172509	09-02-2004	Takeda et al.	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				

Examiner Signature		Date Considered	
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